

Docket No.: 4590-340

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	EXPEDITED PROCEDURE
	:	Response under 37 CFR 1.116
Pierre-Oliver LEFORT et al.	:	Confirmation No. 6495
	:	
U.S. Patent Application No. 10/510,385	:	Group Art Unit: 2813
	:	
Filed: October 6, 2004	:	Examiner: Thanh T. NGUYEN
For:		PROCESS FOR FABRICATING A MICROSTRUCTURE CONTAINING A VACUUM CAVITY, AND MICROSTRUCTURE

**AMENDMENT AND RESPONSE UNDER 37 CFR § 1.116**

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Commissioner for Patents  
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Sir:

This paper is submitted in reply to the Office Action mailed September 18, 2007, which was made Final. Applicants respectfully request that the following amendments **as to form** be entered to place this application in condition for allowance.

**Amendments to the Claims** - page 2 of this paper.

**Remarks/Arguments** - page 5 of this paper.